| FORM PTO-1449 | US DEPARTMENT OF COMMERCE |
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| | PATENT AND TRADEMARK OFFICE |

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| Applicant: |
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| *Shoupu Chen, et al* |

### LIST OF ART CITED BY APPLICANT
*(Use several sheets if necessary)*

| Filing Date  12 march 2001 | Group  2621 |
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#### U.S. PATENT DOCUMENTS

| Examiner Initial* | DOCUMENT NUMBER | DATE | NAME | CLASS | SUBCLASS | FILING DATE IF APPROPRIATE |
| --- | --- | --- | --- | --- | --- | --- |
| ✓ | 09/383,573 | | Nathan D. Cahill et al. | 382 | 154 | 8/25/99 |
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| ✓ | 09/572,522 | | Lawrence A. Ray et al. | 396 | 106 | 5/17/00 |
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#### FOREIGN PATENT DOCUMENTS

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| --- | --- | --- | --- | --- | --- | --- |
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#### OTHER ART *(Including Author, Title, Date, Pertinent Pages, Etc.)*

| Examiner | |
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| ✓ | "Practical Method of Optimization" by R. Fletcher. Second Edition. John Wiley & Sons, pp. 100-107. |
| ✓ | "Proceedings of the 1975 International Conference on Cybernetics and Society". IEEE Systems, Man, and Cybernetics Society. September 23-35, 1975, pp. 163-165. |
| ✓ | "VRML 2.0 Sourcebook" by Andrea L. Ames, David R. Nadeau, and John L. Moreland. Second Edition. John Wiley & Sons, Inc., pp. 63-75. |
| ✓ | "Panoramic Stereo Imaging System with Automatic Disparity Warping and Seaming" by Ho-Chao Huang and Yi-Ping Hung. Graphical Models and Image Processing, Vol. 60, No. 3, May, pp. 196-208. 1998. |

| EXAMINER | DATE CONSIDERED  5-4-04 |
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.